

(19)

Europäisches Patentamt

European Patent Office

Office européen des brevets



(11)

EP 0 738 904 A1

(12)

## EUROPEAN PATENT APPLICATION

(43) Date of publication:

23.10.1996 Bulletin 1996/43

(51) Int. Cl.<sup>6</sup>: G02B 3/00

(21) Application number: 96106114.0

(22) Date of filing: 18.04.1996

(84) Designated Contracting States:

DE ES FR GB IT

(30) Priority: 19.04.1995 IT TO950312

(71) Applicant: MAGNETI MARELLI S.p.A.

I-20145 Milano (IT)

(72) Inventors:

- Perlo, Pierro  
I-12048 Sommariva del Bosco (IT)
- Sinesi, Sabino  
I-10045 Piosasco (IT)
- Sardi, Luca  
I-10057 Sant' Ambrogio Torinese (IT)

• Alessandretti, Giancarlo

I-10146 Torino (IT)

• Monk, John

c/o Magneti Marelli S.p.A.

I-10078 Venaria Reale (IT)

• Masuelli, Stefania

I-10043 Orbassano (IT)

• Bartoncini, Renzo

I-10045 Piosasco (IT)

(74) Representative: Plebani, Rinaldo et al

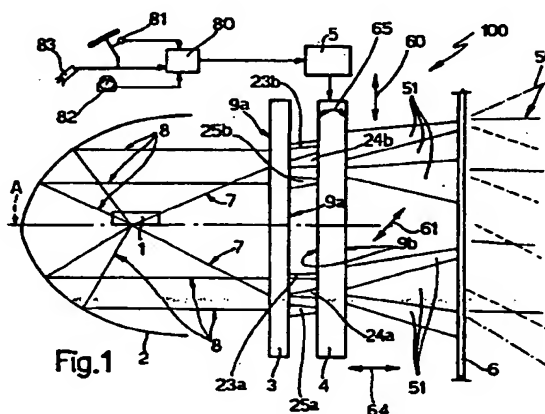
c/o Studio Torta,

Via Viotti 9

10121 Torino (IT)

### (54) Adaptive illumination device, in particular vehicle headlight

(57) Adaptive illumination device, in particular a vehicle headlight, able to emit a plurality of light beams with different preset characteristics (for example main beam, dipped beam, fog beam, etc.), the device including a light source of any kind, a first and a second transparent support arranged in front of the source and provided, respectively, with first and second optical elements, a reflector arranged on the opposite side from the supports in order to direct towards the latter respective light rays emitted by the source not directly towards them, actuator means for moving the supports relatively in front of the source, and a possible transparent protection screen; the first optical elements are each defined by an individual microoptic and are arranged on the first support to form a first matrix of microoptics; the second optical elements are each defined either by a group of mutually differing microoptics arranged adjacent or by an individual microoptic having optical characteristics varying as a function of position, arranged to form on the second support a second matrix of microoptics cascaded with the first ones; the first matrix generates a plurality of vergence-controlled microbeams which will be intercepted selectively at different points of the corresponding second elements of the second matrix consequent upon a relative shifting of the two supports, generating an overall beam defined by the summation of the microbeams as they emerge from the elements of the second matrix.



EP 0 738 904 A1

## Description

The present invention relates to an adaptive illumination device which is particularly useful for use as a vehicle headlight.

It is known that in order to provide ideal illumination, the shaping of the light beam emitted by a headlight should be modified dynamically as a function of the conditions of travel of the vehicle, for example taking account of the speed, of the steering angle, of the inclination of the road and/or of the vehicle (this being linked with the latter's conditions of load), as well as of the meteorological conditions (fog, rain) and/or of external factors (illumination). For example, the simplest of such dynamical shapings is the passage from main beam to dipped beam when crossing with other vehicles.

Currently, passage from one condition of illumination to the other is obtained either using multiple illumination devices (for example, main lamp, dipped lamp, fog lamp, etc.), or else using bulky, expensive and inflexible electromechanical devices, for example servo-systems which rotate the whole headlight physically with respect to the bodywork in order to vary the direction of propagation of the beam on a bend or else to vary the conditions of load of the car; or else, servo mechanisms which act on full-aperture optics (i.e. acting on the whole of the beam) arranged in cascade.

In the field of optics, furthermore, it is known to obtain a deflection at a preset angle of a monochromatic light beam through the use of two matrices of microoptics arranged in cascade, and one of which is movable relative to the other matrix by means of piezoelectric actuators (W. Goltsoz and M. Holz, "Optical Engineering" vol. 29, page 1392, 1990). A further known solution is that of the so-called "beam expanders", i.e. a pair of convergent/divergent (or vice versa) matrices of microoptics arranged aligned along the optical axis one in front of the other, at a distance along the optical axis which can be controlled by actuators; the vergence of the beam obtained is varied by varying this distance. Here and in the following description "vergence" is understood to mean the angle of aperture of the beam (which, when it is equal to  $0^\circ$  defines collimated beams, all the rays being parallel, when it is greater than  $0^\circ$  defines divergent beams and, when it is less than  $0^\circ$ , defines convergent beams). On the other hand for "geometric characteristics" is to be intended the totality of the geometrical characteristics which govern the propagation of a beam, i.e. its direction, its inclination with respect to the optical axis of the illumination device, and its vergence.

The above solutions, based on microoptics, however, besides not exhibiting, apparently, the flexibility required to solve the problem, have never been applied to headlights or, in general, to the adaptive shaping of a beam, both monochromatic and polychromatic.

The aim of the invention is to provide an adaptive illumination device, i.e. one capable of rapidly varying not only the vergence, but also all the other distribution

parameters of an emitted light beam, in such a way as to be able to adapt, in the case of vehicle headlights, the light emitted to the conditions of travel and/or ambient conditions, using any single light source. The aim of the invention is also to provide a compact and reliable device which is relatively simple to construct.

According to the invention there is therefore constructed an adaptive illumination device, in particular a vehicle headlight, able to emit selectively a plurality of light beams with different preset characteristics, of the type comprising a light source, a first and a second transparent support arranged in front of the source and provided, respectively, with first and second optical elements, a reflector arranged on the opposite side from the supports in order to direct towards the latter respective light rays emitted by the source not directly towards the supports, and actuator means for moving the supports relatively in front of the source; characterized in that the first optical elements are each defined by an individual microoptic and are arranged on the first support to form a first microoptics matrix able to generate, for each element, a corresponding microbeam controlled in its overall geometric characteristics; in combination, the second optical elements defining on the second support a second microoptics matrix arranged in cascade with the first; each said second optical element consisting either in an individual microoptic having optical characteristics varying over the area covered thereby, or in a group of preset number of mutually differing microoptics arranged adjacent to one another, and being sized such as the said microbeams will be intercepted selectively at different points having different optical properties by the second elements consequent upon a relative shifting (translation, rotation or rototranslation) of the two supports, selectively generating the said plurality of light beams, each of which results from the summation of the microbeams emerging from the elements of the second matrix.

Therefore, the second matrix of microoptics comprises a number of microoptics greater than (or equal to) that of the first optical elements of the first matrix. In particular, the microoptics forming the said first matrix are all mutually identical microoptics or, at most, differ from one another, exhibiting exclusively predefined phase variations with respect to one another. Furthermore, when each said second optical element forming the second matrix of microoptics is defined by a single microoptic this microoptic is an hybrid one, for instance it is a microoptic shaped at its edge and so sized to comprise at least two zones apt to contribute to beam shaping in a different way.

In this way, by means of suitable relative shiftings of the two supports, it is possible to cascade a plurality of mutually differing microoptics (or of regions having different optical characteristics of one and the same complex microoptic) of the second matrix with each microoptic of the first matrix, thereby obtaining the generation of a plurality of overall light beams also with mutually completely differing characteristics.

For example, by prearranging in the second matrix a suitable quantity of micromasks and of elements able to vary the intensity distribution of the beam, it will be possible to convert a main beam into a dipped beam or the latter into a fog beam. Similarly, by prearranging suitable deviating microoptics in the second matrix, it will be possible to vary the vergence of the beam leaving the device, in such a way as to follow a bend or a gradient.

Obviously, the variations in distribution and shape of the beam will be obtainable under the manual control of the user (for example passing from main to dipped and vice versa), or else will be controllable automatically, for example by operating the actuator means through a central control unit connected to at least one of the following sensors: steering angle sensor, vehicle speed sensor, sensor of meteorological conditions, for example wetness of the road, visibility, etc.

Preferably, finally, the microoptics of the said first matrix are of a type each able to generate a microbeam having geometrical characteristics identical to those of at least one of the said beams with preset characteristics to be generated, and also control at least part of the intensity distribution of such a beam, the microoptics of said first matrix being of a type able to vary the intensity of each of the said microbeams individually. In this way, the tasks of shaping and distributing the plurality of beams which can be generated with the device of the invention become subdivided between the two matrices of microoptics, making it possible to perform with the second matrix solely intensity redistribution operations (which may go as far as the suppression of individual rays) or operations directing the microbeams generated by the first matrix.

Further aims and advantages of the present invention will emerge clearly from the following description of a few non-limiting exemplary embodiments thereof, given with reference to the figures of the attached drawings, in which:

- Figure 1 represents a schematic view in elevation of a vehicle headlight made according to the invention and of its control system;
- Figure 2 illustrates schematically a few alternative embodiments of a constructional detail of the device of Figure 1;
- Figures 3 and 4 exemplify two possible types of matrices of microoptics which can be used in the device of Figure 1;
- Figures 5, 6 and 7 illustrate three different types of optical element which can be used in the device of the invention;
- Figure 8a illustrates a portion of a matrix of rectangular microlenses;
- Figure 8b illustrates the far field pattern of the matrix of microlens described in Figure 8b;
- Figure 9a illustrates microoptics shaped with the typical periphery that defines the dipped output beam of a headlamp;

- Figure 9b is the far field on a screen at 25 m given by the array of Figure 9a sized 120 mm in diameter and illuminated by the beam emitted by an automotive incandescent source with an aluminium protecting cover and a parabola with focal = 15.88 mm and external diameter 116 mm;
- Figure 10a illustrates two matrices in cascade where the first matrix is composed of microlenses and the second matrix is composed of both microlenses and microprisms with the microlenses in position;
- Figure 10b illustrates the two matrices of Figure 10a with a shift applied to the second matrix in such a way that the prisms are in position;
- Figure 11a illustrates a first matrix of microoptics located on annulus and Figure 11b illustrates the corresponding second matrix of microoptics where per each element of the first matrix there is a group of two microoptics which can be selected at different times;
- Figure 12 illustrates a portion of a matrix of monofocal lenses with different focals; and
- Figure 13 illustrates the variation of the divergence of the envelope beam exiting the two matrices starting from an F number of the overall system equal 2.

With reference to Figures 1 and 2, indicated overall as 100 is an illumination device, in this instance a vehicle headlight, essentially comprising a casing (which is known but not illustrated for the sake of simplicity) inside which are arranged a light source 1 and a reflector 2, and which is closed externally (for example in a fluid-tight manner) by a transparent screen 6 arranged somehow in front of the reflector 2 and the source 1. According to the invention, furthermore, inside the aforesaid casing are also housed, again in front of the source 1 and the reflector 2, but before the screen 6, two transparent supports 3 and 4, arranged aligned along the optical axis of the reflector 2, indicated as A, and each defined by a plane lamina made from a heat-resistant glass or plastic material; each support 3, 4 is delimited by a respective pair of surfaces or faces, indicated respectively as 9a for the support 3 and as 9b for the support 4, arranged in series in front of the source 1 with respect to the path of the light rays 7, 8 emitted thereby.

In this instance, the reflector 2 is arranged on the opposite side from the supports 3, 4 with respect to the source 1 and is able to direct towards the faces 9a, 9b respectively light rays 8 emitted by the source 1 not directly towards the faces 9a, 9b. On the other hand these receive, directly, the rays 7 emitted by the source 1 towards the supports 3, 4. According to the invention, two matrices 10, 11 (Figures 3 and 4) in cascade (with respect to the path of the rays 7 and 8) of optical elements 12 and, respectively, 13, are arranged on either one of the faces 9a of the support 3 and on either one of the corresponding faces 9b of the support 4.

The light source 1 may be of any type, able to emit monochromatic, polychromatic, coherent, partially coherent or fully incoherent light; for example it may be a filament (incandescent), gas, ion discharge or solid-state polymeric bulb, or consist of a laser; in the case in which there is no desire to utilize the direct rays 7, furthermore, the source 1 can be masked in a known way with an appropriate blanking hood arranged beside the supports 3, 4. The reflector 2 is conversely defined by a reflecting surface generated by revolving one or more base curves and, generally, is a conventional parabolic reflector; it is therefore extremely simple and economical to construct. Similarly, the outer transparent screen 6 is preferably completely smooth and devoid of any optical function and can therefore be made in any shape (plane, curved, etc.) and arranged at any inclination, even very steep, with respect to the optical axis A.

In case of necessity and/or having recourse to a favourable positioning, the screen 6 may however also be endowed with optical functions, for example of traditional prismatics, or carry internally, on the side pointing towards the supports 3, 4, optical elements of the type of the elements 12, 13, however distributed and however made on the support. For example, the matrices 11, 12 are preferably made directly on the faces 9a and 9b by injection molding of plastics such as polycarbonate or PMMA or according to a known technology are made on transparent polymeric film which is in turn applied as a liquid coating to the respective faces 9a and 9b of the substrate then UV polymerised on the substrate with the relieved master in position. Where the thermal load on the first matrix may be of concern the first matrix could be made on glass substrate; conventional stamping, dry and wet etching are usable as well.

According to what is illustrated schematically in Figures 2, 3 and 4, the optical elements 12 and 13 of the matrices 10 and 11 each consist either of an individual microoptic of any perimetral shape, or of a group 15 of a preset number, for example four, of microoptics, which are mutually identical or different from one another, arranged immediately adjacent to one another, of any perimetral shape, but however such as to be conjugate with the perimetral shape of the other adjacent microoptics of the same group. The size of the elements in the two matrices defines the working principle of the optical components. When the size is several millimetres and for instance the microoptics are spherical lenses refraction dominates, when the size is below 3 mm the effect of diffraction begins to be effective and the shape of the single microoptics becomes to be important for the final far field pattern to be obtained. It is a novelty of this invention to use such kind of hybrid effects to shape and chromatically correct polychromatic beam as well as monochromatic light beams. The elements in the two matrices have sizes such that diffraction at the periphery defining each element is a crucial part of the design. Such kind of hybrid optical components can be of several types for instance the single microoptics can be a spherical microlens whose centre works in refraction

and the edge introduces diffraction. But it can be a high efficiency purely diffractive lens. In this case it can be supposed that the central part works like a refractive one while its periphery contributes by diffraction to define the shape of the exiting beam. In a more general sense hybrid optic is here intended as optical components, parts of a matrix, sized in such a way that the shape of the elements contributes to define the shape of the exiting pattern. An extreme case but a significant one is the matrix of purely binary two levels diffractive lenses, if it is shaped rectangular with proper size and relief height it defines a rectangular uniform beam in the far field. The optical elements 12 forming the matrix 10 (Figures 2c, 2d and 3) are each defined by an individual microoptic. In this instance, the microoptics 12 forming the matrix 10 can all be mutually identical, for example all microoptics of hexagonal shape 12c (Figure 2d) or else of elliptical shape 12b (Figure 2c), or else can be microoptics having the same perimetral shape but exhibiting predefined phase variations one with respect to another, for example can consist of multifocal and/or monofocal microlenses with different focal lengths 16, 17, 18, 19, 20, 21, 22, etc. (shown schematically in Figure 3). In every case, the microoptics making up the optical elements 12 are each able to generate a corresponding microbeam controlled in all its geometric characteristics (vergence etc.); for example (Figure 1) on passing through the matrix 10 the rays 7, 8 will generate respective collimated microbeams 23a and 23b, the first parallel to the optical axis A and the second inclined with respect to the axis A, respective divergent microbeams 24a, 24b at a different inclination with respect to the axis A and with a different "aperture" angle, and respective convergent microbeams 25a, 25b.

On the other hand (Figures 2a, 2b, 4) in the matrix 11 each element 13 is formed by groups 15 of microoptics of rectangular (Figures 1a, 4), rhombic (Figure 2b) or any other shape, able to intercept selectively, in different relative positions, the microbeams 23, 24, 25, etc. emitted by the matrix 10. Conversely, according to the embodiment of Figure 7, each element 73 consists of a singular complex microoptic 35 having optical characteristics varying over the area covered thereby, so as to be apt to intercept selectively microbeams 23, 24, 25 in different points of such area having different optical properties. In both cases, the optical properties of each optical element 13 of the matrix 11 are therefore dependent on the relative position of the matrix 11 with respect to the matrix 10. According to embodiment of Figures 4, 5, 6 for each element 12 of the first matrix there is a group 15 of microoptics in the second matrix which form a multiple element 13; the periphery enclosing that group of elements is coupled both in shape and in size to the one of the single element of the first matrix: namely, it is the perimeter or shape and size of group 15 that is equal to the single microoptics of the first array 10 (see Figure 8 and Figure 9). Each optical element 13 is so formed by an identical group of four mutually differing

adjacent microoptics 30, 31, 32, 33, or else by (Figures 5 and 6) mutually different groups, for example 15a, 15b, etc., of microoptics again all mutually different. If as a special case the element of the first matrix is rectangularly shaped  $L \times L/N$  the element of the group corresponding in the second matrix can be squared  $L/N \times L/N$ . If  $N=3$  there will be 3 different microoptics in the group making up the single element of the second array, if  $N=4$  there will be 4 microoptics and more in general with  $N=1,2,3,4,5, \dots$  any integer number limited by technological aspects only. If the single element in the first array is squared  $L \times L$  each microoptics in the group can be squared  $L/N \times L/N$  with  $N=1,2,3,4,5, \dots$ ; with  $N=4$  there will be  $N \times N=16$  different microoptics per each element in the first matrix.

Considering the first matrix  $A_{K,M}$  as a whole with  $K \times M$  elements we can indicate the single element with  $a_{ij}$  with  $i=1,2,3,4 \dots$  and  $j=1,2,3,4 \dots$ . If the microoptics are all equal for instance rectangular sized  $L \times H$  and the element in the corresponding group of the second matrix are all rectangular sized  $L/N \times H/S$  per each microoptics of the first matrix there are  $N \times S$  different microoptics in the second array.

For example the matrix 11 can contain one or more groups 15a each comprising four microoptics consisting of a multifocal lens 36, a multi-order grating 37, a mask 38 and a hologram 39; or groups 15b comprising for instance four microoptics (which can be two, three, five, six, etc.) consisting of a prism 40, a multi-order lens 41, an aspherical lens 42 and a cylindrical lens 43. The group 15a or 15b is repeated all over the matrix 11 equal to itself or for a better control of both beam shape and distribution and of the cromatism could be repeated with slightly different elements in their phase function.

It is clear that, by virtue of the structure described, by moving the supports 3, 4 relatively, the relative position of the cascaded microoptics 12 and 13 is varied thereby causing the microbeams 23, 24, 25, etc. generated by the matrix 10 to be intercepted selectively at different points of the complex optical elements 13 (Figures 6 and 7) having different optical characteristics, thereby generating, selectively (Figure 1), a plurality of overall light beams 50 passing through the screen 6; each one of which results from the summation, coherent, incoherent or partially coherent, of respective microbeams 51 emerging from the elements 13 of the matrix 11.

To obtain correct operation, the optical elements 13 forming the matrix 11 have to be present in a number greater or equal to that of the corresponding optical elements 12 of the matrix 10, and, in every case, each must have an area greater than that projected onto the matrix 11 by each of the corresponding microbeams 23, 24, 25, etc. generated by the matrix 10, which projections are represented schematically in Figures 6 and 7 with dashed and heavy solid lines respectively. In such a way, matrix 11 comprises always a number of microoptics greater than (or at least equal to) that of elements 12 of matrix 10.

According to a further characteristic of the invention, finally, the microoptics 12 making up part of the first matrix 10 are chosen of a type such that the microbeams 23, 24, 25, etc. generated by them each already have, as inherent geometrical characteristics, all those same geometrical characteristics which it is desired to obtain for at least one of the overall beams 50 generated by the device 10. In combination with such a characteristic, the microoptics defining the optical elements 13 of the second matrix will be chosen of a type also able to modulate in a preset manner, individually or contemporaneously, the microbeams intercepted by them in one or more of the following quantities: intensity, distribution and polarization. Consequently, the overall beams 50 produced by the device 10 will be generated, according to the invention, by the superposition of all the microbeams generated by the microoptics 12 and, possibly, modified in their characteristics other than those which are purely geometrical, by the microoptics 13.

Microoptics meeting this specification may be of the most disparate types; for example, each microoptic defining (or making up) a complex element 12 or 13 can be defined by a known individual optical element describable by a complex transmission function of analytical type suitably discretized, or else of digital type (for example the elements 37 and 39 of Figure 5), in which the function describes the presence of binary codes defined by relieves (high/low), continuous profiles or by barriers (pass/no-pass); therefore, the microoptics defining the complex elements 12, 13 may be of pure phase, i.e. able to transmit all the incident light, or else of amplitude, i.e. which absorb or reflect a portion of the beam incident thereon; for example, the micromasks 38 to be used in the matrix 11 can be structured micromasks of the grey levels or amplitude binary type.

For better control of the uniformity of the overall light beam, in the case of polychromatic sources 1, phasewise differing microoptics are used for the complex elements 12, as already described, for example ones which differ from one another only through the phase constant, which varies in relation to the position of the microoptic in the matrix. More generally, the microoptics defining the elements 12 can be refractive microoptics, diffractive microoptics or hybrid refractive-diffractive microoptics, whereas the microoptics defining the complex elements 13 will be exclusively of diffractive or hybrid refractive-diffractive type; as already described, furthermore, the microoptics of the matrix 10 can be shaped (Figure 2c, 2d, 8 and 9) to control not only the geometrical characteristics of the microbeams 23, 24, 25, etc., but also, at least within certain limits, to vary the intensity of each microbeam individually, in such a way as to control, already with the matrix 10, at least part of the intensity distribution of the overall beams 50, since a definite shape of outline, combined with a definite type of microoptic already provides a preset divergence; hence the appropriate combination of the geometry of the microlenses with their optical char-



acteristics enables a modification of the shape and intensity of the individual microbeams to be obtained simultaneously. An example of rectangular microoptics is illustrated in Figures 8a and 8b. A further example is illustrated in Figure 9a where the microoptics are shaped with a periphery that defines the typical dipped beam of a headlamp. The periphery is inscribed in a rectangle size 2.5 mm x 1.2 mm. The corresponding far field pattern is illustrated in Figure 9b.

Specific types of microoptic which are preferred in order to embody the invention comprise two-level or multilevel or continuous relief, pure phase binary diffractive elements, of the computer-generated hologram type, prismatic elements of diffractive or microrefractive type and, specifically for the microoptics of the matrix 10, diffractive, refractive or hybrid general aspherical elements.

According to a preferred and important variant of the invention, one of the microoptics making up each group 15 of the matrix 11 is made as an element of the computer-generated hologram type (such as 39 of Figure 5) shaped in such a way as to vary the state of polarization of the microbeams intercepted by it; this variant is particularly useful for devices 10 intended to be used as headlights: in this way, in fact, by moving either the support 4 or 3 in such a way as to intercept with these elements all the microbeams generated by the matrix 10 it is possible to attenuate or prevent dazzling when crossing while preserving beams having high luminous intensity. According to requirements, some of the microoptics of the matrix 11 can also consist of plane transparent elements of the window type, so as not to vary the characteristics of the microbeams intercepted by such elements.

Preferred optical elements for embodying the microoptics of the matrices 10 and 11 are also sub-wavelength diffractive structures, otherwise known as zero-order diffractive structures, or else elements able to generate a high number of light spots, of the type: fanout gratings, multi-order gratings, Dammann gratings, and their generalizations having symmetrical or asymmetrical structures. In fact, these particular elements make it possible to attenuate or solve, as will be seen, the problem of the generation of chromatic aberrations in the overall beam, which are connected with the shifts in the wavelength distribution of the light rays produced by microoptics. Solutions of chromatic correction are here considered as those per which at all angles of the far field both diffracted and refracted rays overlap with relative intensities such as the beam has specified chromatic coordinate, i.e. white light.

A first solution to the abovementioned problem, consists in using for the matrix 10 microoptics exhibiting dispersive chromatic characteristics opposite to those of the corresponding microoptics of the matrix 11; so, for example, in conjunction with microoptics of diffractive type for the matrix 11, it will be necessary to use microoptics of exclusively refractive type for the matrix 10. A second solution to the problem is to be mindful that at

least one of the two matrices 10, 11 consists exclusively of pure-phase microoptics of the kinoform type, of higher order than the first one, which consist of hybrid refractive-diffractive microlenses which are sufficiently thick to obtain refraction and are provided with relieves of different height arranged as a grating, to obtain diffraction. Kinoforms of order higher than four have been proved to be sufficiently adequate for chromatic control of lighting devices.

A further solution to the problem is to use for either the matrix 10 or 11 microoptics of monofocal type, all differing from one another and distributed in the matrix in such a way as to correct the chromatic aberrations present in the overall beam 50. In this instance such as to obtain a combination of white light through the effect of the coherent addition of the individual microbeams. Figure 12 is such an example of a matrix with monofocal lenses with different focals introduced to reduce the residual chromatic aberration; increased beam uniformity has been proved as well.

Another possible solution is to use matrices of microoptics composed of diffractive multifocal elements, like the elements 16, 22 schematically illustrated in Figure 3 and the real element 36 illustrated in Figure 5; this way, the microbeams generated, focused in multispots along the optical axis per each wavelength are recombined in the overall beam 50.

A further solution, adaptable in the case described earlier of the use for the matrices 10, 11 of elements able to generate a high number of light spots, such as fanout, Dammann, etc. gratings (Figure 5, element 37), is finally to use microoptics devised to produce a partial superposition between the light spots generated by the microoptics of the matrix 10 with those produced by the microoptics of the matrix 11; in fact, such partial superposition, if properly devised, produces a recombination of the chromatic aberrations present in the individual microbeams around preset wavelengths, in this instance white light. A description of the method of producing a very high number of spots is given for instance in the paper "Analytical initial approximation for multi-order binary grating design"; L. Doskolovitch et al in Pure ed Applied Optics.3 (1994) pages 921-930.

In use, the support 3 is fixed with respect to the source 1, whereas the support 4 is connected to an actuator 5, which may be an actuator of any known type, for example an electromechanical, piezoelectric, polymorphic, magnetorestrictive, electrostatic transducer, etc., able to move the support 4 relative to 3 in accordance with one, two or more of the modes indicated by arrows in Figure 1, for example to shift the support 4 vertically and/or horizontally (i.e. perpendicularly to the plane of the sheet) (arrows 60 and 61, with 61 being illustrated in perspective), to move the support 4 away from/towards 3 parallel to the optical axis A (arrow 64), or again to rotate the support 4 in such a way as to vary its inclination with respect to the optical axis A (arrow 65). In a preferred embodiment the microoptics are located in annulus such as those illustrated in Fig-

ure 11. Figure 11a represents the first matrix 10 and Figure 11b illustrates the second matrix 11 in cascade. Per each element 12 of the first matrix 10 there are group of two microoptics 15 forming a corresponding element 13 in the second matrix 11. The selection of one of the two being possible by a simple rotation of one of the matrix. Disposition of the microoptics on spirals are possible and easily implementable.

These movements are controlled by operating the actuator 5 (or a series of actuators 5 each specialized to effect an individual movement described) by means of a central control unit 80, which is able to receive commands from a user, via respective push-buttons/switches which are not illustrated, or else signals from, for example, a sensor 81 of the steering angle, a sensor 82 of vehicle speed, a sensor 83 of meteorological conditions (wetness, mist, etc.) so as to process them with a program stored in this facility, so as to generate respective commands for the actuator 5.

In every case, the relative movements between the supports 3 and 4 (it is obviously possible also to move both the supports 3, 4 or else to keep 4 still and move only 3) determine relative shifts between elements 12 and elements 13 which cause (Figures 6 and 7) one and the same microbeam produced by the matrix 10 to fall on different zones (at least two) of a corresponding complex (or hybrid) microoptic 35 of the matrix 11 (microoptics shaped at its edge and sized such as said different zones are able to contribute in a different manner at the beam shaping), or on different microoptics of the same group 15 of the matrix 11, or again, in the case in which the groups 15 are fewer in number than the elements 12, straddling two different microoptics 42, 43 of one and the same group 15 of the matrix 11. In this fashion, each microbeam generated by the matrix 10 can be "processed" and corrected by the matrix 11 in intensity, wavelength distribution and polarization in a plurality of different ways (in this instance, at least four different ones in the case of the matrix 11 formed by groups 15 of four elements and present in identical number to that of the elements 12), consequently generating overall beams 50 with different distributional characteristics; for example provided with cut-offs; see Figure 5 element 38 (therefore suitable to constitute anti-fog beams or dipped beams), having a different vergence (therefore able to illuminate one and the same sector differently).

It is also clear that the control described may be accomplished not only in discrete mode, but also in continuous mode, in which case, by using microoptics such as 35, whose optical characteristics vary continuously over its area, it will for example be possible to vary the inclination (lateral and/or vertical) of the beam 50 continuously as a function of the steering angle, so as, for example, to follow a bend by rotating the beam 50 as a function of the position of the vehicle on the bend.

## Performance of a typical preferred embodiment

With reference to Figure 1 and Figures 9a, 9b using an aluminium protected coated parabola with focal  $F=15.88$  mm cut with an external exiting diameter of 116 mm, a H1 source typically used in the automotive, a matrix of uncoated glass of microoptics shaped such as those in Figure 9a inscribed in a rectangle of 2.5 mm x 1.2 mm, and similarly with polycarbonate, the far field pattern (on standard screen at 25 m) is reported in Figure 9b. The measured efficiency of the system, ratio of the flux emitted by the source and the flux exiting the system, has been measured to be 72%. The use of sources with metallic covers simplify the control of the beam, in fact the amount of direct light is totally eliminated.

For this sizes of the microoptics in the array the adaptability of the system is obtained by actuators of relatively modest accuracy, because resolution in the micron range is not needed, while stabilization to vibrations, and mechanical and thermal loads resistance is needed. Though several forms of low cost actuation are possible the most effective proved to be the conventional e/m step motor. Continuous e/m and piezo motors have been successfully experimented as well.

In a typical solution the adaptive performance of the system has been implemented by a telescopic arrangement illustrated in Figure 10a where two positive microoptics are combined. If for instance the microoptics of the first matrix 10 is composed of squared spherical microlenses with focal  $F$ , height  $H$  and  $F$  number  $K$ , when the second matrix 11, composed of spherical microlenses with focal  $F/2$  and the same  $F$  number  $K$ , are located at a distance  $F/2$  from the first matrix the  $F$  number of the overall system is halved to  $K/2$ . The technological implications associated to the fabrication of devices with small  $F$  numbers needed to obtain the correct divergence of the headlamp beam are then equally divided in the construction of both two matrices 10, 11.

The control of the divergence can be obtained by varying the spacing between the two matrices 10 and 11. Figure 13 illustrates the variation of the divergence of the envelope beam exiting the two matrices starting from an  $F$  number of the overall system equal 2. An actuation of few millimetre proved to be sufficient for the typical divergence adaptive control of headlamp.

Figure 10b proves in comparison with Figure 10a the effect of switching from one microoptic 15a of the second matrix to another microoptic 15b of the same group forming each element 13, in this case from a microlenses 15a to a prism 15b illustrated in analogical form; the beam, respectively 50a and 50b, changes its direction. This situation is particularly exiting useful in many cases of driving.

## Claims

1. Adaptive illumination device, in particular a vehicle headlight, able to emit selectively a plurality of light

beams with different preset characteristics, of the type comprising a light source, a first and a second transparent support arranged in front of the source and provided, respectively, with first and second optical elements, a reflector arranged on the opposite side from the supports in order to direct towards the latter respective light rays emitted by the source not directly towards the supports, and actuator means for moving the supports relatively in front of the source; characterized in that the first optical elements are each defined by an individual microoptic and are arranged on the first support to form a first microoptics matrix able to generate, for each element, a corresponding microbeam controlled in its overall geometric characteristics; in combination, the second optical elements defining on the second support a second microoptics matrix arranged in cascade with the first; each said second optical element consisting either in an individual microoptic having optical characteristics varying over the area covered thereby, or in a group of preset number of mutually differing microoptics arranged adjacent to one another, and being sized such as the said microbeams will be intercepted selectively at different points having different optical properties by the second elements consequent upon a relative shifting (translation, rotation or rototranslation) of the two supports, selectively generating the said plurality of light beams, each of which results from the summation of the microbeams emerging from the elements of the second matrix.

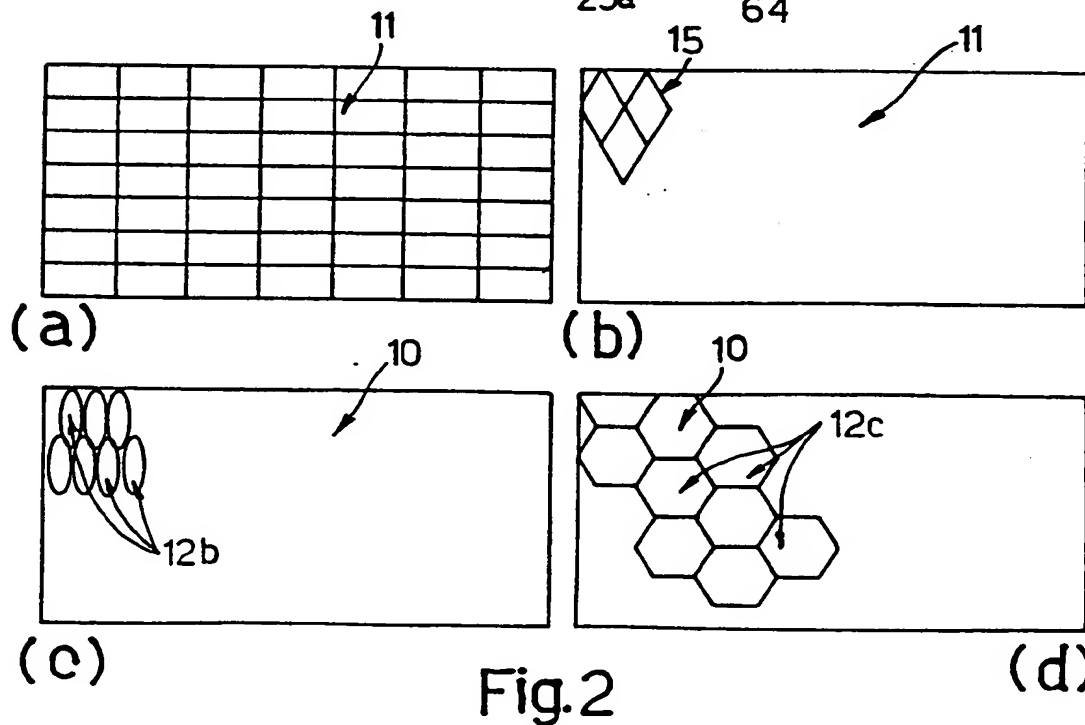
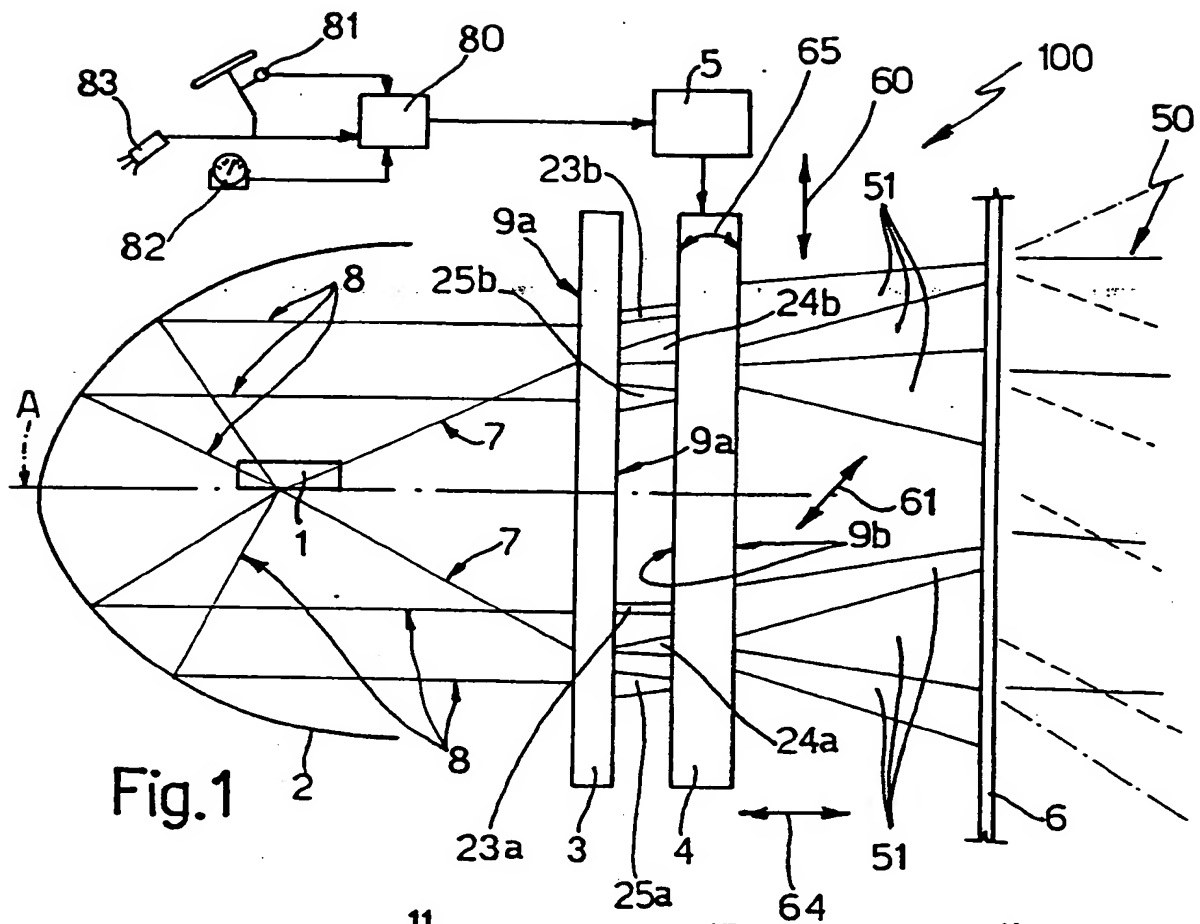
2. Adaptive illumination device according to Claim 1, characterized in that each said second optical element of the second matrix is defined by an individual hybrid microoptic or by a microoptic so shaped at its edge and so sized to have at least two zones apt to contribute in a different manner at the beam shaping.
3. Adaptive illumination device according to one of the preceding claims, characterized in that the microoptics forming the said first matrix are all mutually identical microoptics.
4. Adaptive illumination device according to any one of Claim 1 or 2, characterized in that at least some of the microoptics forming the said first matrix differ from one another, exhibiting exclusively predefined phase variations with respect to one another.
5. Adaptive illumination device according to Claim 4, characterized in that the said phase variations are constant, periodic or quasi-periodic.
6. Adaptive illumination device according to one of the preceding claims, characterized in that the microoptics of the said first matrix are each of a type able to generate a microbeam having geometrical char-

acteristics identical to those of at least one of the said beams with preset characteristics to be generated.

7. Adaptive illumination device according to Claim 6, characterized in that the first microoptics also control at least part of the intensity distribution of at least one of the said beams with preset characteristics, being of a type able to vary the intensity of each of the said microbeams individually.
8. Adaptive illumination device according to any one of the preceding claims, characterized in that the microoptics of at least one of the said first and second matrices have a perimetral outline of a shape and dimension such as to determine, independently of the optical characteristics of the microoptic, a modification of the shape and/or of the intensity of the said microbeams.
9. Adaptive illumination device according to any one of the preceding claims, characterized in that the said second matrix of microoptics comprises a number of microoptics greater than or equal to that of the said first optical elements of the first matrix of microoptics and each have areas greater than that projected onto the second matrix by each of the corresponding microbeams generated by the first matrix of microoptics.
10. Adaptive illumination device according to Claim 9, characterized in that the second optical elements forming the second matrix of microoptics are all identical to one another.
11. Adaptive illumination device according to Claim 9, characterized in that at least some of the second optical elements forming the second matrix of microoptics differ from one another.
12. Adaptive illumination device according to any one of the preceding claims, characterized in that the microoptics with which the said first and second matrices are formed are chosen from the group consisting in: refractive microoptics, diffractive microoptics, hybrid refractive-diffractive microoptics, respectively of pure phase or of amplitude and of analytical or digital type.
13. Adaptive illumination device according to any one of the preceding claims, characterized in that the said light source is chosen from the group consisting in: filament, gas, ion discharge or solid-state polymeric bulbs; the said reflector being defined by a reflecting surface generated by revolving one or more base curves; and the said device furthermore comprising an outer transparent screen arranged in front of the said supports so as to be traversed by the said plurality of overall beams.



14. Adaptive illumination device according to Claim 13, characterized in that the said outer transparent screen is completely smooth and devoid of any optical function. 5
15. Adaptive illumination device according to any one of the preceding claims, characterized in that the microoptics forming the said second matrix comprise prismatic elements of diffractive or microrefractive type. 10
16. Adaptive illumination device according to any one of the preceding claims, characterized in that the microoptics forming the said second matrix comprise diffractive, refractive or hybrid general aspherical elements. 15
17. Adaptive illumination device according to any one of the preceding claims, characterized in that the microoptics forming the said second matrix comprise two-level or multilevel or continuous relief pure phase binary diffractive elements, of the computer-generated hologram type. 20
18. Adaptive illumination device according to Claim 17, characterized in that the said microoptics of the said second matrix comprise elements of the computer-generated hologram type shaped in such a way as to vary the state of polarization of the microbeams intercepted by the second matrix. 25
19. Adaptive illumination device according to any one of the preceding claims, characterized in that the microoptics forming the said second matrix comprise plane transparent elements of the window type, so as not to vary the characteristics of the microbeams intercepted thereby. 30
20. Adaptive illumination device according to any one of the preceding claims, characterized in that the microoptics forming the said second matrix comprise structured micromasks of the grey levels or amplitude binary type: 35
21. Adaptive illumination device according to any one of the preceding claims, characterized in that the microoptics forming the said second matrix comprise subwavelength diffractive structures (zero-order diffractive structures). 40
22. Adaptive illumination device according to any one of the preceding claims, characterized in that at least the microoptics forming the said second matrix are of a type able to generate a high number of light spots, for example of the type: fanout gratings, multi-order gratings, Dammann gratings, and their generalizations having symmetrical or asymmetrical structures. 45
23. Adaptive illumination device according to any one of the preceding claims, characterized in that the microoptics of the first matrix exhibit dispersive chromatic characteristics opposite to those of the corresponding microoptics of the second matrix. 50
24. Adaptive illumination device according to any one of Claims 1 to 21, characterized in that the microoptics of the first matrix are exclusively of refractive type.
25. Adaptive illumination device according to any one of Claims 1 to 21, characterized in that at least one of the said first and second matrices of microoptics consists exclusively of pure-phase microoptics of the kinoform type of higher order than the first one.
26. Adaptive illumination device according to any one of Claims 1 to 21, characterized in that the microoptics of the second matrix are monofocal microoptics which differ from one another and are distributed in the second matrix in such a way as to correct the chromatic aberrations present in the microbeams around preset wavelengths.
27. Adaptive illumination device according to any one of Claims 1 to 21, characterized in that at least one of the said first and second matrices of microoptics is composed of multifocal microoptics.
28. Adaptive illumination device according to Claim 22, characterized in that the microoptics of the second matrix are able to produce a partial superposition between the light spots generated by the first and/or the second optical elements such as to determine a far field correction of the chromatic aberrations present in the said microbeams.
29. Adaptive illumination device according to any one of the preceding claims, characterized in that the said actuator means are able to shift one or both of the said supports with respect to the said source.
30. Adaptive illumination device according to any one of the preceding claims, characterized in that the said actuator means comprise at least one transducer chosen from the group consisting in: electro-mechanical, piezoelectric, polymorphic, magnetorestrictive, electrostatic transducers.
31. Adaptive illumination device according to any one of the preceding claims, characterized in that the said actuator means are controlled by a central control unit connected to at least one of the following sensors: steering angle sensor, vehicle speed sensor, meteorological conditions sensor.



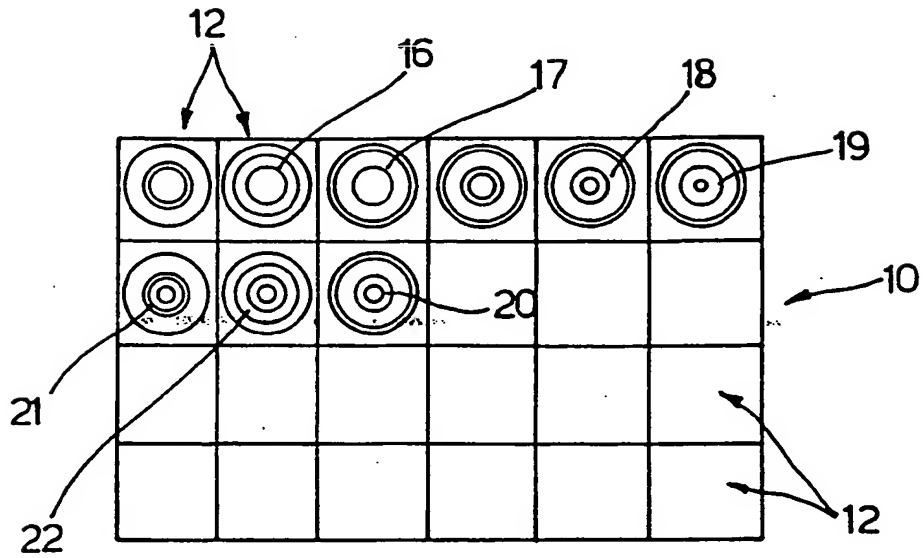


Fig. 3

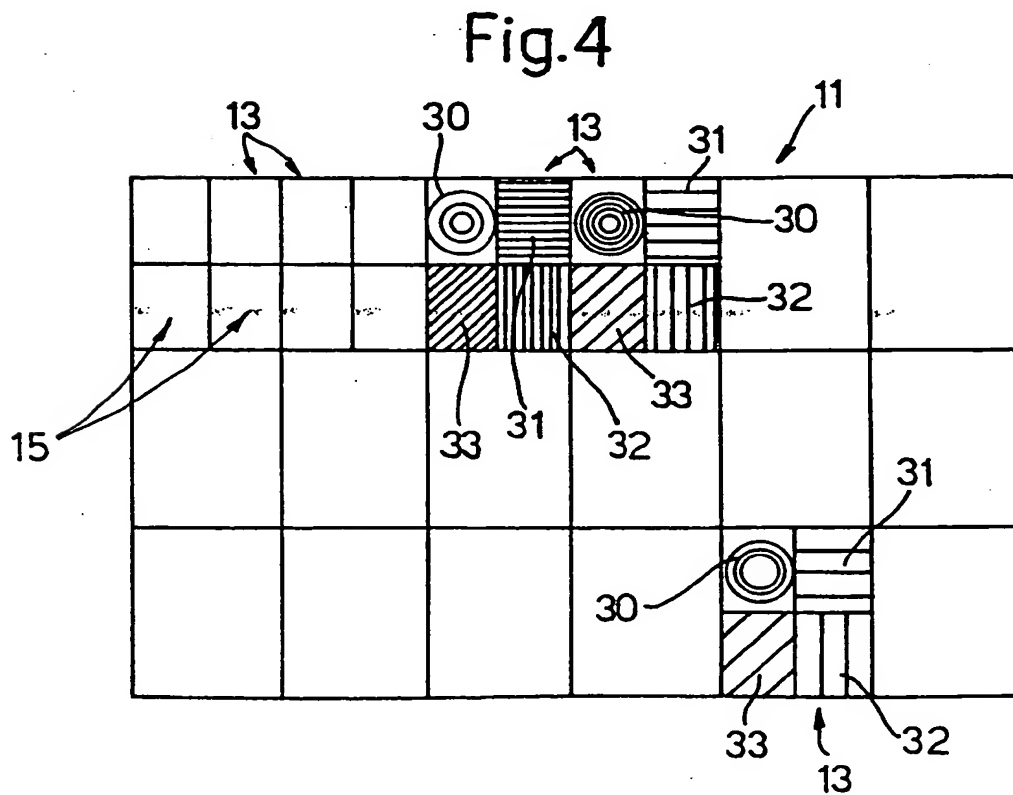


Fig. 4

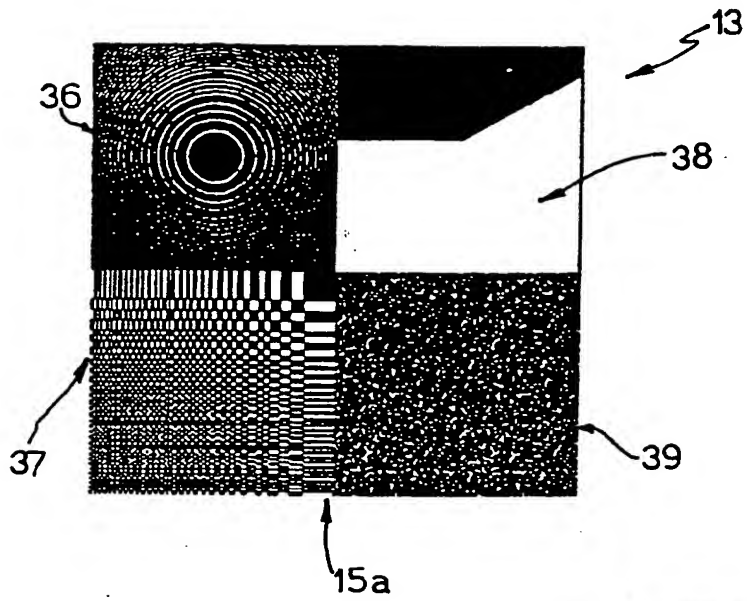


Fig. 6

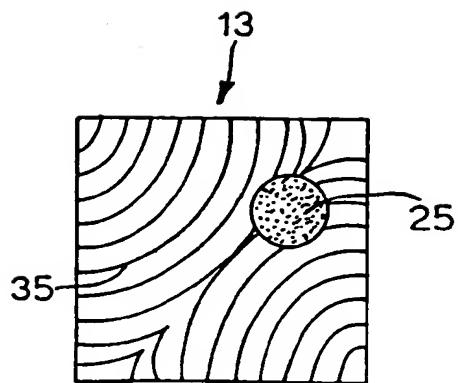
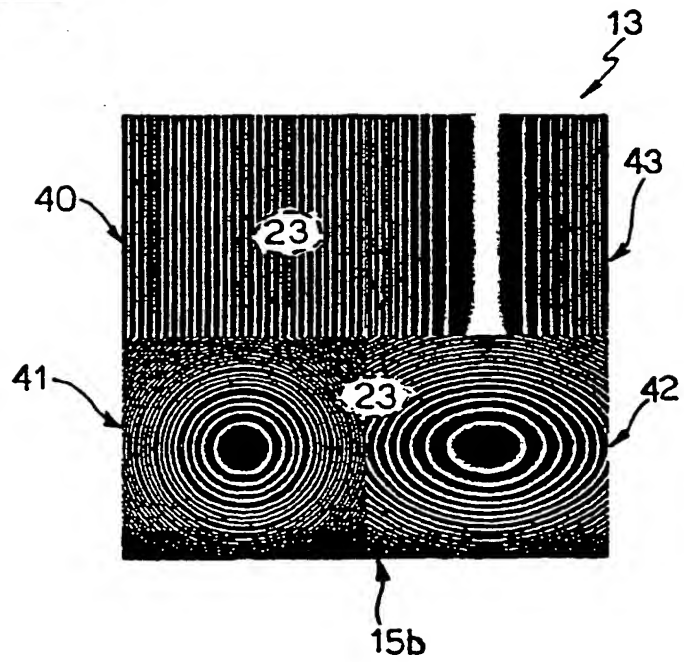


Fig. 7

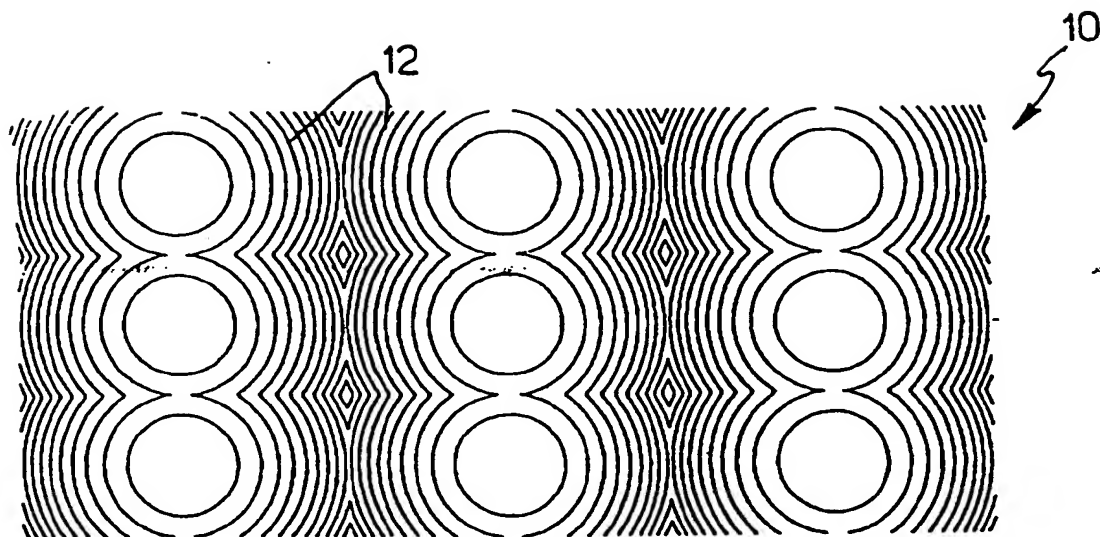
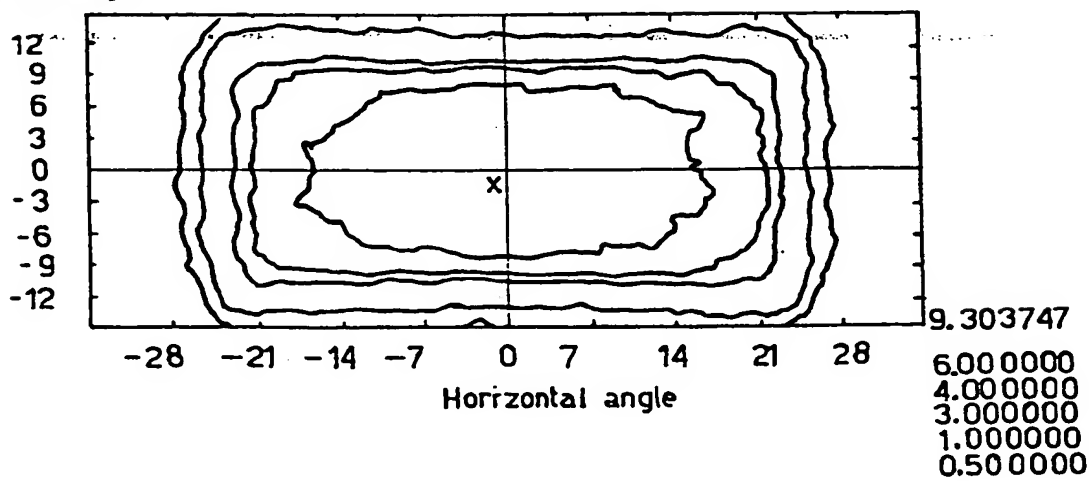


Fig. 8a

Fig. 8b

Vertical angle



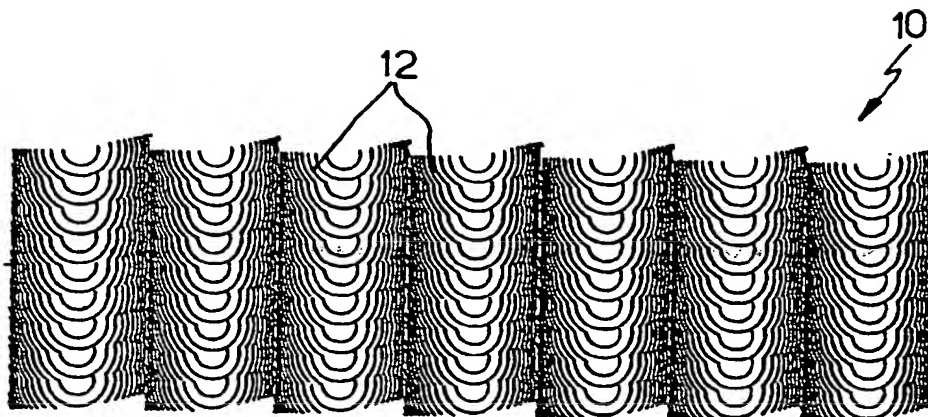


Fig. 9a

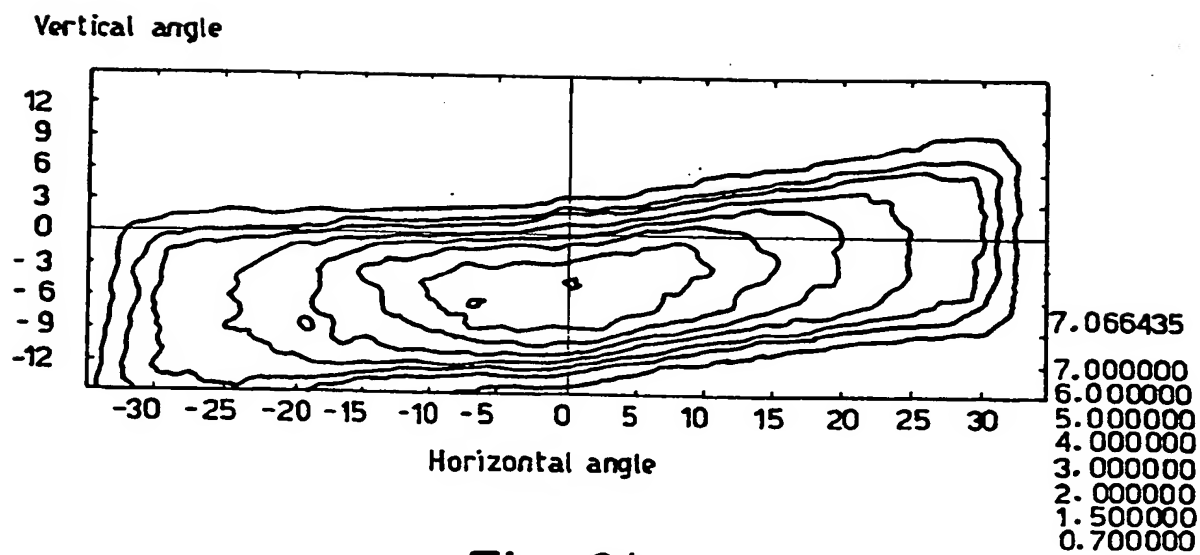


Fig. 9b



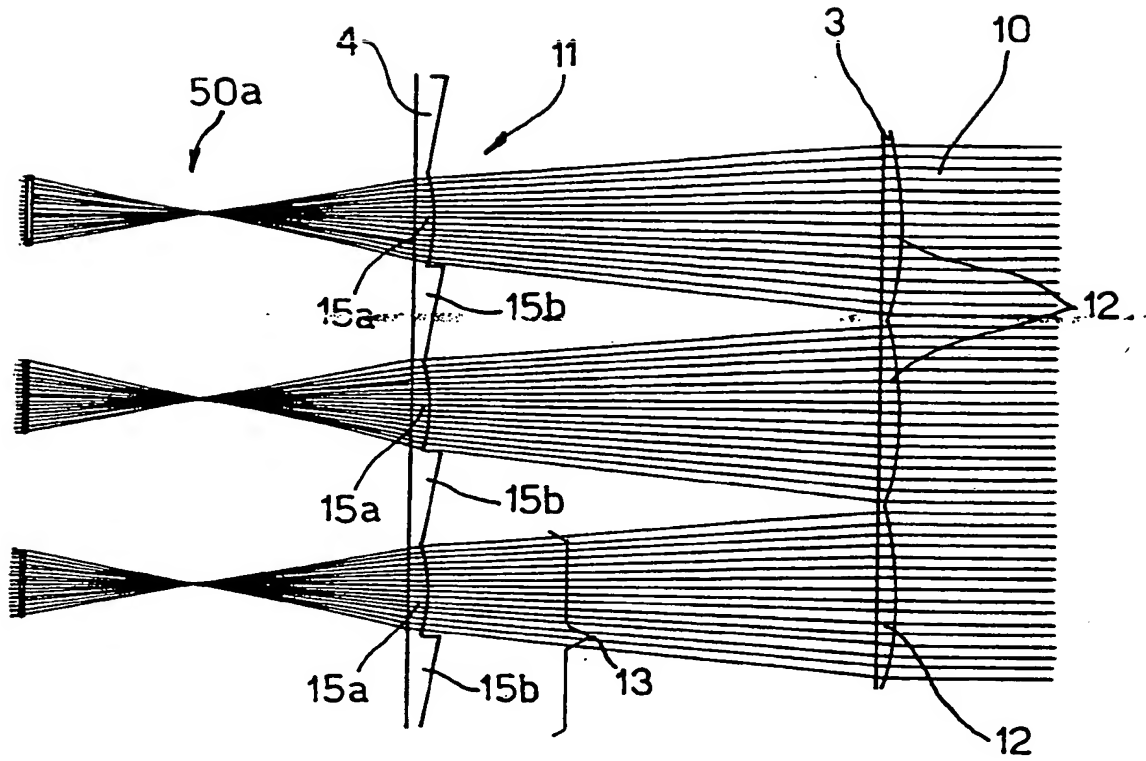


Fig. 10a

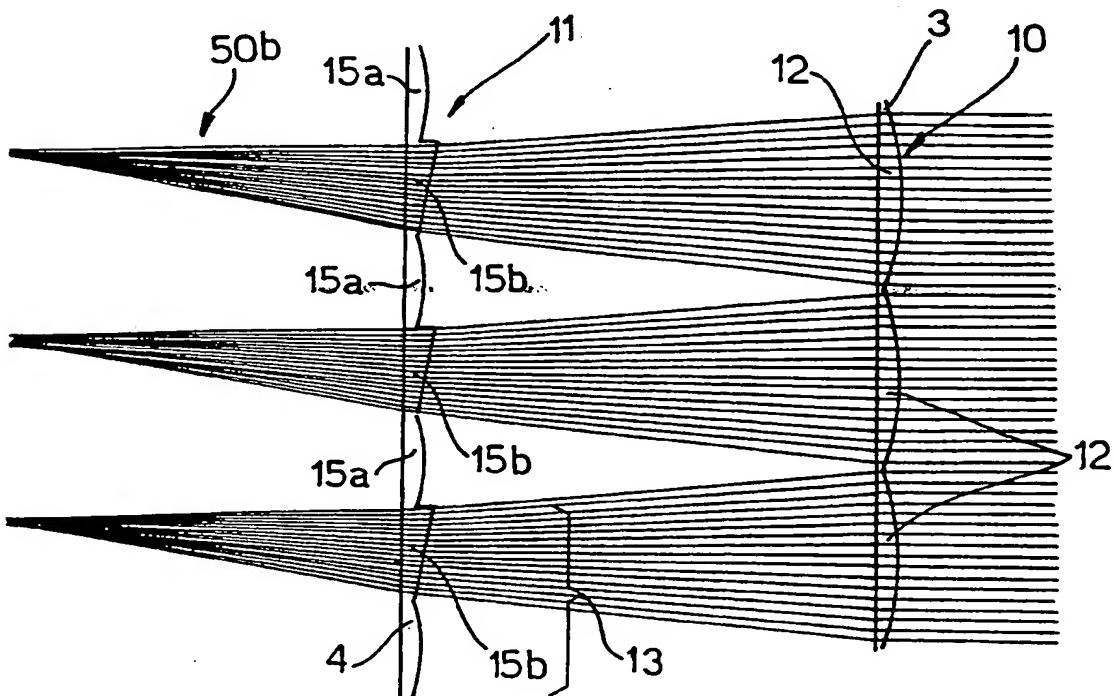


Fig. 10b

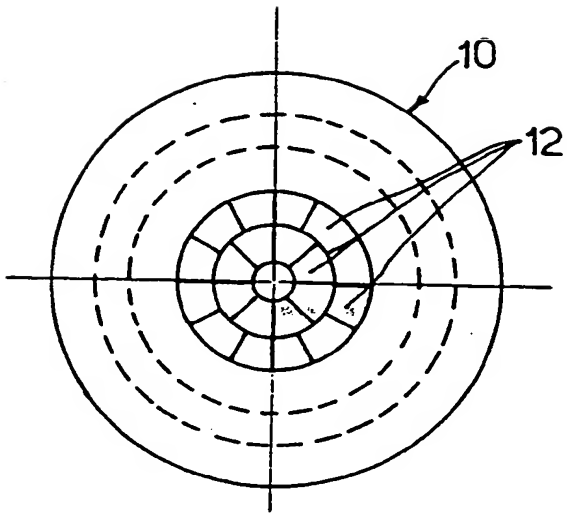


Fig. 11a

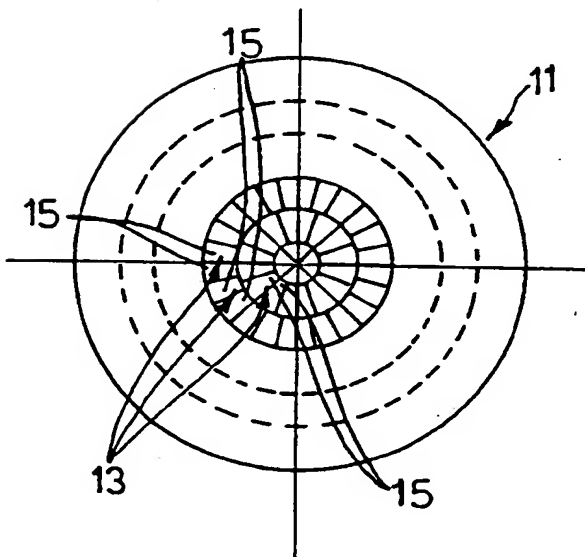
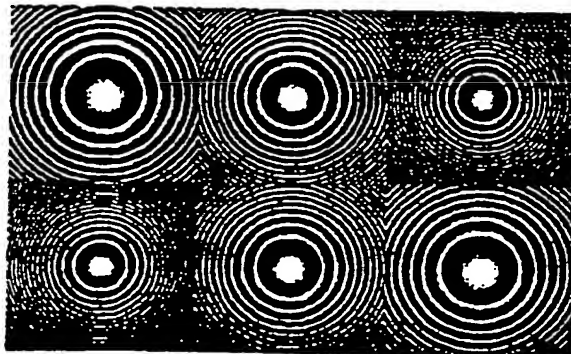


Fig. 11b

Fig. 12



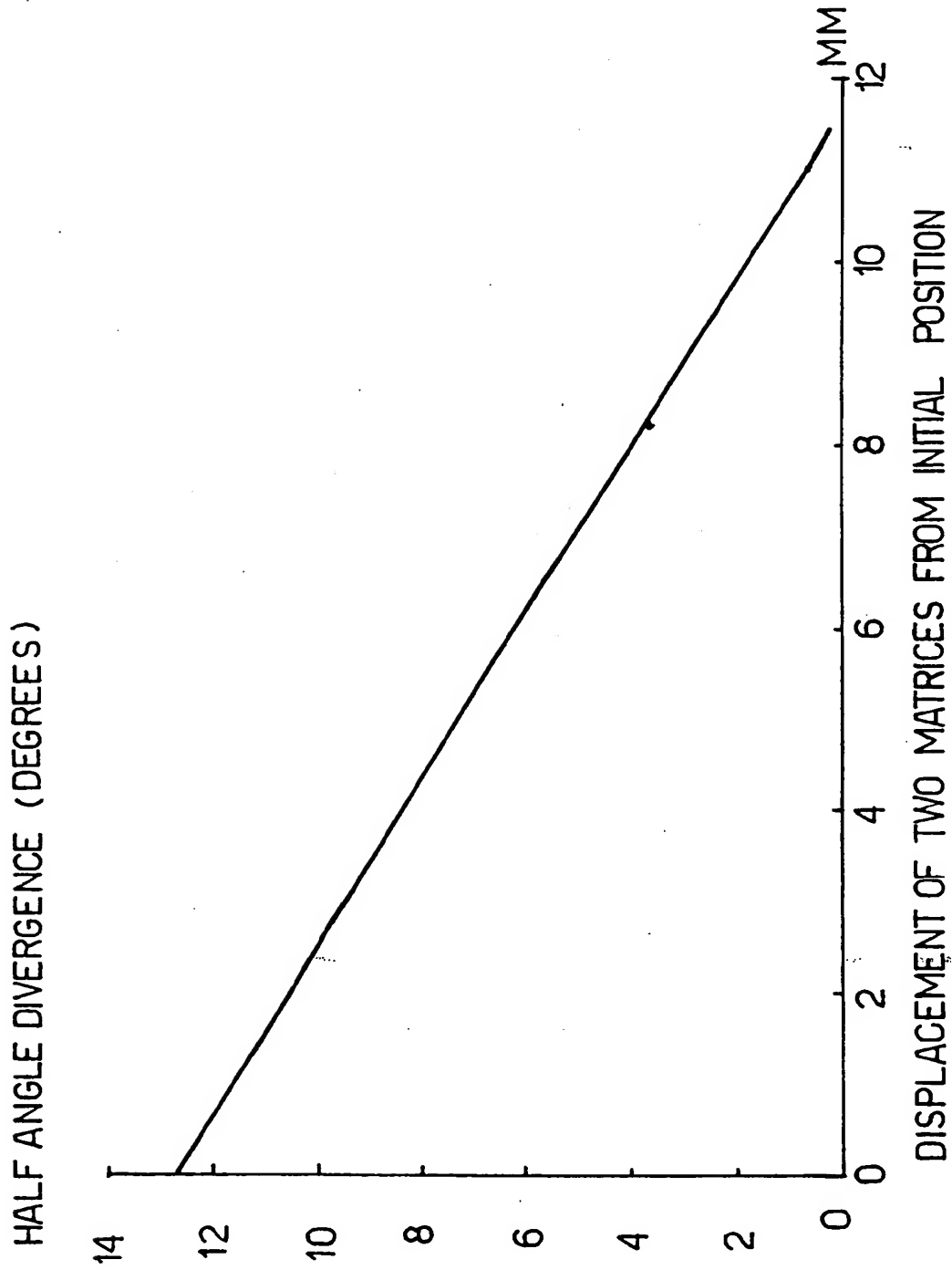


Fig.13



European Patent  
Office

# EUROPEAN SEARCH REPORT

Application Number  
EP 96 10 6114

| DOCUMENTS CONSIDERED TO BE RELEVANT                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                           |                                                                                                                                                                                                                   |                                                         |                                              |
|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|-------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|---------------------------------------------------------|----------------------------------------------|
| Category                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                      | Citation of document with indication, where appropriate, of relevant passages                                                                                                                                     | Relevant to claim                                       | CLASSIFICATION OF THE APPLICATION (Int.Cl.6) |
| Y                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                             | WO-A-94 18582 (APA OPTICS, INC.) 18 August 1994<br>* claims 1,6; figures 2A, 2B, 3 *                                                                                                                              | 1                                                       | G02B3/00                                     |
| Y                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                             | EP-A-0 563 874 (MATSUSHITA ELECTRIC INDUSTRIAL CO. ) 6 October 1993<br>* page 5, line 10 - line 24; figure 1 *                                                                                                    | 1                                                       |                                              |
| A                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                             | OPTICAL ENGINEERING,<br>vol. 33, no. 11, November 1994, BELLINGHAM US,<br>pages 3616-3623, XP000475105<br>M.E. MOTAMED ET AL.: "miniaturized micro-optical scanners"<br>* the whole document *                    | 1                                                       |                                              |
| D,A                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                           | OPTICAL ENGINEERING,<br>vol. 29, no. 11, November 1990, BELLINGHAM US,<br>pages 1392-1397, XP002008083<br>W. GOLTSOS ET AL.: "agile beam steering using binary optics microlens arrays"<br>* the whole document * | 1                                                       |                                              |
| The present search report has been drawn up for all claims                                                                                                                                                                                                                                                                                                                                                                                                                                                                                    |                                                                                                                                                                                                                   |                                                         | TECHNICAL FIELDS SEARCHED (Int.Cl.6)         |
|                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                               |                                                                                                                                                                                                                   |                                                         | G02B<br>F21Q<br>F21M                         |
| Place of search<br><b>THE HAGUE</b>                                                                                                                                                                                                                                                                                                                                                                                                                                                                                                           |                                                                                                                                                                                                                   | Date of completion of the search<br><b>11 July 1996</b> | Examiner<br><b>Sarneel, A</b>                |
| <b>CATEGORY OF CITED DOCUMENTS</b><br>X : particularly relevant if taken alone<br>Y : particularly relevant if combined with another document of the same category<br>A : technological background<br>O : non-written disclosure<br>F : intermediate document<br>T : theory or principle underlying the invention<br>E : earlier patent document, but published on, or after the filing date<br>D : document cited in the application<br>L : document cited for other reasons<br>& : member of the same patent family, corresponding document |                                                                                                                                                                                                                   |                                                         |                                              |

EPO FORM 150 01.82 (P/C01)

**This Page is Inserted by IFW Indexing and Scanning  
Operations and is not part of the Official Record**

## **BEST AVAILABLE IMAGES**

Defective images within this document are accurate representations of the original documents submitted by the applicant.

Defects in the images include but are not limited to the items checked:

- ☐ **BLACK BORDERS**
- ☐ **IMAGE CUT OFF AT TOP, BOTTOM OR SIDES**
- ☐ **FADED TEXT OR DRAWING**
- ☐ **BLURRED OR ILLEGIBLE TEXT OR DRAWING**
- ☐ **SKEWED/SLANTED IMAGES**
- ☒ **COLOR OR BLACK AND WHITE PHOTOGRAPHS**
- ☐ **GRAY SCALE DOCUMENTS**
- ☐ **LINES OR MARKS ON ORIGINAL DOCUMENT**
- ☐ **REFERENCE(S) OR EXHIBIT(S) SUBMITTED ARE POOR QUALITY**
- ☐ **OTHER:** \_\_\_\_\_

**IMAGES ARE BEST AVAILABLE COPY.**

**As rescanning these documents will not correct the image problems checked, please do not report these problems to the IFW Image Problem Mailbox.**